

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q83324

Kenji YAKUSHIJI

Appln. No.: 10/573,017

Group Art Unit: 2812

Confirmation No.: 2532

Examiner: Not Yet Assigned

Filed: January 19, 2007

For: METHOD FOR FABRICATION OF SEMICONDUCTOR LIGHT-EMITTING DEVICE
AND THE DEVICE FABRICATED BY THE METHOD

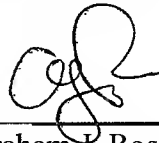
STATEMENT UNDER 37 C.F.R. § 1.97(e)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Sir:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed concurrently herewith was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of said Information Disclosure Statement.

Respectfully submitted,



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WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: July 17, 2008